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For: Phase Shift Fringe Analysis Method and Apparatus Using th

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U.S. PATENT DOCUMENTS					
Examiner Initials*	U.S. Patent Document Number	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY		

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS				
Examiners Initials*	Include Author (CAPITAL-LETTERS), title of article, book, magazine, etc. date, page(s), volume-issue number(s), publisher, city and/or country where published	T**		
MIL	MITSUO TAKEDA, "Subfringe Interferometry Fundamentals", <u>Kogaku</u> , February 1984, pp. 55-65, Vol. 13, No. 1, Japan			
Mor	KATHERINE CREATH, "Phase-Measurement Interferometry Techniques", <u>Progress in Optics</u> , E. Wolf, Editor, 1988, pp. 349-393, Vol. XXVI, Elsevier Science Publishers B.V., New York, U.S.A.			

Examiner Signature Date Considered April	1 21,2004
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^{*}Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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